

INFORMATION DISCLOSURE CITATION	ATTY. DOCKET NO. 249-245 APPLICANT	SERIAL NO. 10/053576 UNKNOWN
TOMONARI et al. FILING DATE January 24, 2002		GROUP 2834

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DMY	5,058,856	10/1991	GORDON et al.	251	11	
DMY	5,069,419	12/1991	JERMAN	251	11	
DMB	5,271,597	12/1993	JERMAN	251	11	
DMY	5,059,133	10/1991	HIKAMI et al.	434	16	
DMB	5,870,007	2/1999	CARR et al.	333	262	
DMY	5,920,417	7/1999	JOHNSON	359	223	
DMB	6,044,646	4/2000	SILVERBROOK	60	528	
DMB	6,114,794	9/2000	DHULER et al.	310	307	
DMB	1,258,368	3/1918	SMITH	194	283	
DMY	4,115,750	9/1978	HANSEN et al.	337	107	
DMB	6,087,638	7/2000	SILVERBROOK	219	540	
DMB	6,124,663	9/2000	HAAKE et al.	310	307	

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

Duk	"Silicon Microvalves for Gas Flow Control" Phillip W. Barth, Ph.D. Hewlett-Packard Laboratories pp 276-279 The 8 th International Conference on Solid-State Sensors and Actuators, and Eurosensors IX. Stockholm, Sweden, June 25-29, 1995 (in parent case 09/511,948 now usp 6,384,509)
TMW	"Electrically-Activated, Micromachined Diaphragm Valves" Hal Jerman, IC Sensors Milpitas, CA 95035 pp 363-367 (in parent case 09/511,948; now usp 6,384,509)

Examiner: Stephen M. Dougherty Date Considered 1/24/04
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-EB-0830 (Also PTO-1418)